IN THE CLAIMS

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1	1.	(Three Times Amended) A method of removing a particle from a surface of a
2	meta	plug formed in a via comprising:
3		introducing a first agent to a metal layer;
		polishing the metal layer with the first agent;
5		after polishing the metal layer, introducing a second agent comprising hydrogen
6	perox	ide to rinse the surface of the metal plug; and
7 .		removing at least one particle from the surface of the metal plug.
1	9.	(Three Times Amended) A method of removing at least one particle from a
2	surfac	re of a metal plug disposed over a substrate comprising:
(3) 2	· ·	depositing a slurry onto a metal layer over the metal plug;
4		polishing the metal layer; and
. 5		after polishing the metal layer, rinsing the surface of the metal plug with a
6	soluti	on comprising hydrogen peroxide.
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7	18.	(Three Times Amended) A method comprising:
13		polishing a metal layer over a conductive plug with a slurry;
B		after polishing the metal layer, introducing a rinsing solution onto the conductive
-4-3>	plug,	the rinsing solution comprises hydrogen peroxide.
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